



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 3781**  
Eiichi ISHII et al. : Docket No. 2003\_1290  
Serial No. 10/659,327 : Group Art Unit 1742  
Filed September 11, 2003 :  
METHOD OF SURFACE TREATMENT :  
OF TITANIUM METAL :

**RE: INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In connection with the IDS filed September 11, 2003, please note that an English language abstract of JP 07-090542 cited in the IDS is of record in the now abandoned parent application, Serial No. 09/902,260. The English language abstract was submitted with the IDS of December 31, 2001 in the parent application.

Respectfully submitted,

Eiichi ISHII et al.

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

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